

**Disclaimer**

6,980,012—Randy J. Schwindt, Portland, OR (US); Warren K. Harwood, Vancouver, WA (US); Paul A. Tervo, Vancouver, WA (US); Kenneth T. Smith, Portland, OR (US); Richard H. Warner, Portland, OR (US).  
WAFER PROBE STATION FOR LOW-CURRENT MEASUREMENTS. Patent dated December 27, 2005.  
Disclaimer filed February 25, 2008, by the assignee, Cascade Microtech, Inc.

Hereby disclaims the following complete claims in the above identified patent 1-8.

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